

CRYO POSITIONING STAGE HIGH RESONANCE (CPSHR)

Driven by innovation



Features

- Parallel kinematics, high stiffness design
- High internal resonances, up to 4kHz
- Coarse motion using Cryo Linear Actuators
- 20mK to 375K, vacuum compatible
- CPSHR₁: compact, high resonances, titanium
- CPSHR₂: large stroke, lower resonances, higher thermal conductivity, phosphor bronze
- CPSHR₃: large stroke, high resonances, optimal thermal conductivity, aluminium
- Scanner option "S"
- Cryo Optical Encoder option "COE"

Description / Applications

The Cryo Positioning Stage High Resonance (CPSHR) is a XYZ positioning stage developed for use in a cryo-vacuum environment. Parallel kinematics result in a light and stiff stage with very high internal resonance frequencies, making it less sensitive to floor vibrations. The CPSHR 1 is the most compact design with small stroke and high resonances. The CPSHR2 has large stroke and improved thermal conductivity but lower resonances. The CPSHR3 combines the best of both worlds with large stroke, further optimized thermal conductivity and high resonances.

Specifications

specs	unit	CPSHR1-S	CPSHR2	CPSHR2-S	CPSHR2-COE	CPSHR2-S-COE	CPSHR3	CPSHR3-S	CPSHR3-COE	CPSHR3-S-COE
SYSTEM SPECIFICATIONS										
Active axes	-	3								
Type of motion	-	x, y, z with parasitic RxRy								
System Range *	mm ³	approx. 1x1x1	approx. 10x10x4				approx. 8x8x4			
System scan range @4K	μm ³	approx. 1x1x0.5	N/A	approx. 10x10x1.6	N/A	approx. 10x10x1.6	N/A	approx. 8x8x1.6	N/A	approx. 8x8x1.6
Parasitic angle from xy stroke	mrad/mm	20				14			17	
Coarse actuator	-	CLA2201								
Scanning actuator	-	Piezo ceramic	N/A	Piezo ceramic	N/A	Piezo ceramic	N/A	Piezo ceramic	N/A	Piezo ceramic
Endstops **	-	at z -0.5mm								
Main construction material	-	Titanium	Phosphor Bronze (improved thermal conductivity, lower resonances)				Aluminium (optimal thermal conductivity, high resonances)			
1st natural frequency	kHz	xy:1.5 / z:4,0	xy: 1.2 / z: 2.2	xy: 0.55 / z: 2.2	xy: 1.2 / z: 2.2	xy: 0.55 / z: 2.2	xy: 2 / z: 3:7	xy: 1.5 / z: 3:7	xy: 2 / z: 3:7	xy: 1.5 / z: 3:7
ACTUATOR SPECIFICATIONS										
Specifications are given for individual actuators unless otherwise mentioned. See interface drawing for transformation matrix from actuator outputs to system motion										
Coarse range	mm	±0.5	±3							
Scan range @ 293 K	μm	2.5	N/A	8	N/A	8	N/A	8	N/A	8
Scan range @ 4 K	μm	0.5	N/A	1.6	N/A	1.6	N/A	1.6	N/A	1.6
Coarse step size @ 293 K	nm	5-25								
Coarse step size @ 4 K	nm	1-5								
Scanner sensitivity @ 293 K	nm/V	25	N/A	66	N/A	66	N/A	66	N/A	66
Scanner sensitivity @ 4 K	nm/V	5	N/A	13	N/A	13	N/A	13	N/A	13
Load capacity	grams	100	200							
Operating temperature	K	0.8-375	0.02-375				1.5-375			
Mass	grams	300	1230	1450			510		570	
Coarse actuator spindle pitch	mm/turn	0,25								
Coarse actuator encoder resolution ***	PPR	N/A	N/A	850			N/A		850	
DRIVE ELECTRONICS										
Controller/driver	-	CAB-230(115), CADM2								
Encoder readout	-	N/A	N/A	OEM2			N/A		OEM2	
Scanner module ****	-	Only for systems with -S option : CADM2 or PSM,PSMIL								
* Typical volume for positioning. Due to the parallel kinematics the indicated max values are not necessarily simultaneously achievable. On the other hand max values can be bigger when strokes along other axes are limited.										
** Endstops are placed close to, but not coincident with each actuator motion axis. Together they define a system z-position, with x and y being 0. Touching multiple endstops in an uncontrolled manner with x and y not being 0 can cause the system to jam and could require manual action to free it.										
*** Linear resolution can be found by dividing the spindle pitch by PPR (pulses per revolution)										
**** Specified scan ranges assume use of CADM2 -20V to +130V, 10 bits resolution, setpoint rate approx. 10Hz. Alternative: PSM amplifier with PSMIL -20V to +130V. By disconnecting the PSMIL high voltage bipolar operation is possible to increase the range. This is only allowed at cryogenic temperatures and -120V to +120V is not to be exceeded!										

Mechanical and electrical information

Download 3D-Step files, interface drawings and user manuals from:
<https://www.jpe-innovations.com/cryo-nano-products/>

Contact

For quotations, orders, customization or specials, please contact us at:
<https://www.jpe-innovations.com/contact/>

Ordering Information

CPSHR₁-S /HV

Cryo Positioning Stage High Resonance 1-Scanner

CPSHR₂ /HV

Cryo Positioning Stage High Resonance 2

CPSHR₂-S /HV

Cryo Positioning Stage High Resonance 2-Scanner

CPSHR₂-COE /HV

Cryo Positioning Stage High Resonance 2-Cryo Optical Encoder

CPSHR₂-S-COE /HV

Cryo Positioning Stage High Resonance 2-Scanner-Cryo Optical Encoder

CPSHR₃ /HV

Cryo Positioning Stage High Resonance 3

CPSHR₃-S /HV

Cryo Positioning Stage High Resonance 3-Scanner

CPSHR₃-COE /HV

Cryo Positioning Stage High Resonance 3-Cryo Optical Encoder

CPSHR₃-S-COE /HV

Cryo Positioning Stage High Resonance 3-Scanner-Cryo Optical Encoder